

# Welsh & Katz, Ltd.

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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Attorney Docket No.: 926530-96468

Applicants: Shibata et al.

Serial No. 10/519,152

Filed: August 10, 2005

Examiner: Cheung Lee

Title: POROUS SUBSTRATE AND  
ITS MANUFACTURING  
METHOD, AND GAN  
SEMICONDUCTOR  
MULTILAYER SUBSTRATE  
AND ITS  
MANUFACTURING  
METHOD

### Certificate Under 37 CFR 1.8(a)

I hereby certify that this correspondence is being electronically filed via EFS WEB addressed to: Mail Stop Petition, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on April 28, 2008.

*Colleen M. Dunphy*  
Colleen M. Dunphy

Mail Stop Petition  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

- ☒ [x] AUTHORIZATION TO PAY AND PETITION FOR THE ACCEPTANCE OF ANY NECESSARY FEES. If any charges or fees must be paid in connection with the following Communication (including but not limited to the payment of Issue Fees), they may be paid out of our Deposit Account No. 23-0920. If this payment also requires a Petition, please construe this authorization to pay as the necessary Petition which is required to accompany this payment.
- ☒ [X] Applicant hereby petitions for a Three-month Extension of Time and entry of this Response to Restriction Requirement which is sent on April 28, 2008. The payment of \$2,690.00 for total cost of this filing is being paid by charge card.

*RESPONSE TO RESTRICTION REQUIREMENT*